

# A Circuit Compatible Analytical Device Model for Nanowire FET Considering Ballistic and Drift-Diffusion Transport

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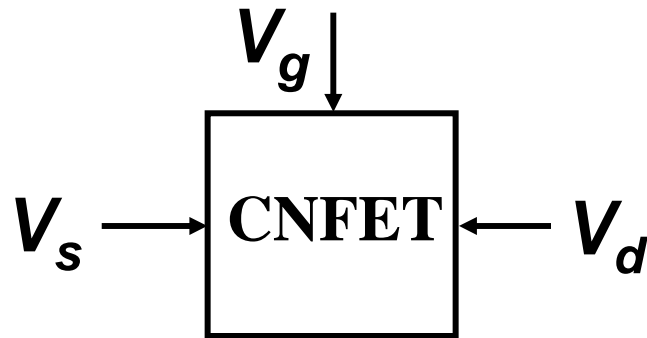
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**TOSHIBA**

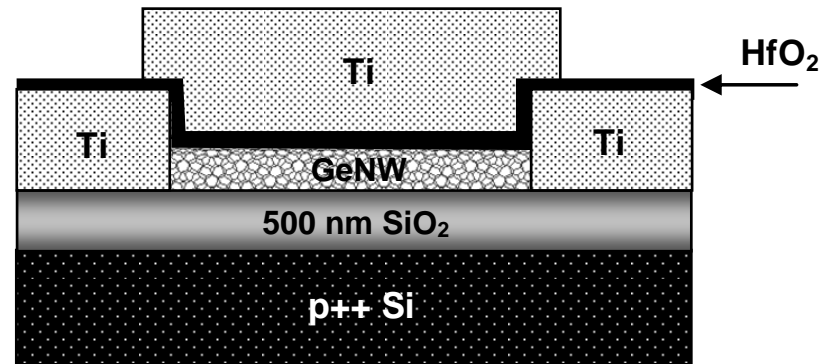
# Objective

To achieve **ANALYTICAL** expression for device electrostatics



$$I_D = f_1(V_g, V_d, V_s)$$

$$C = f_2(V_g, V_d, V_s)$$



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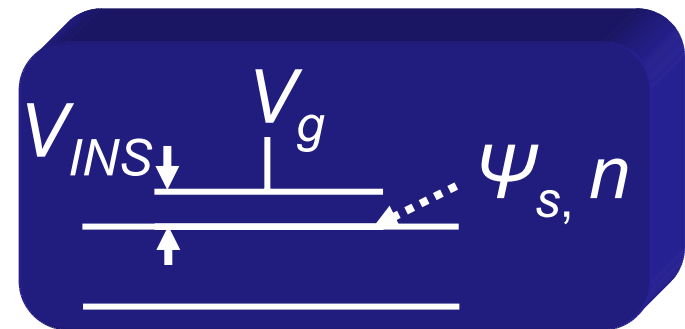
# Challenges

□ To obtain **CLOSED** form integral

$$Q_{NW} = \frac{q\sqrt{2k_B T}}{2\pi\hbar} \sum_n \sum_\nu g_\nu \sqrt{m_\nu^d} \left\{ \int_0^\infty \frac{E^{-1/2} dE}{1 + e^{\left[ \frac{E + E_\nu^n - q\psi_s}{k_B T} \right]}} + \int_0^\infty \frac{E^{-1/2} dE}{1 + e^{\left[ \frac{E + E_\nu^n - q(\psi_s - V_{ds})}{k_B T} \right]}} \right\}$$

□ Solving **SELF- CONSISTENT** equations

$$\psi_s = V_{gs} - V_{INS} = V_{gs} - \frac{Q_{NW}}{C_{INS}}$$



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# Analytical Solution

$$Q_{NW} = \alpha e^{(\psi_s / \beta)} \quad \text{for } V_{gs} < V_T$$

$$Q_{NW} = \lambda_0 + \rho_1 \lambda_1 (\psi_s - \psi_T) + \rho_2 \lambda_2 (\psi_s - \psi_T)^2$$

for  $V_{gs} > V_T$

**Drift-diffusion current:**

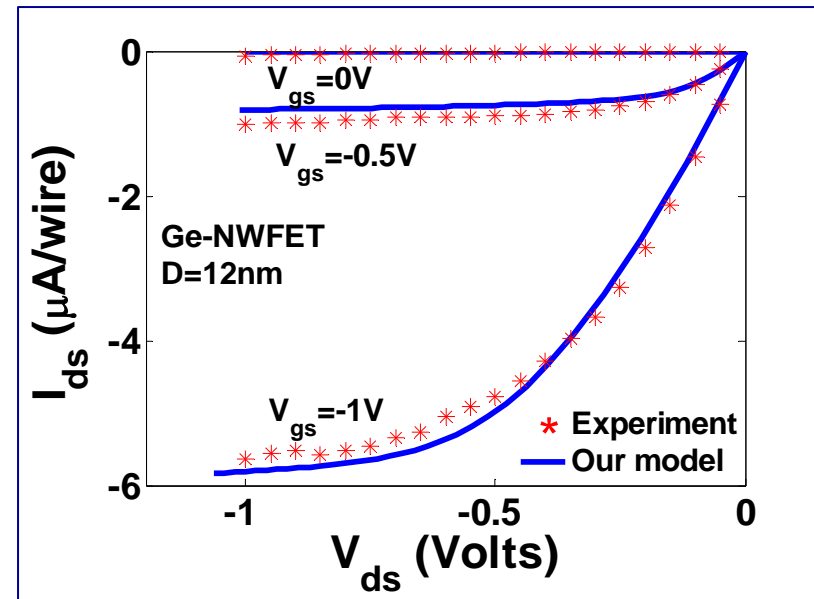
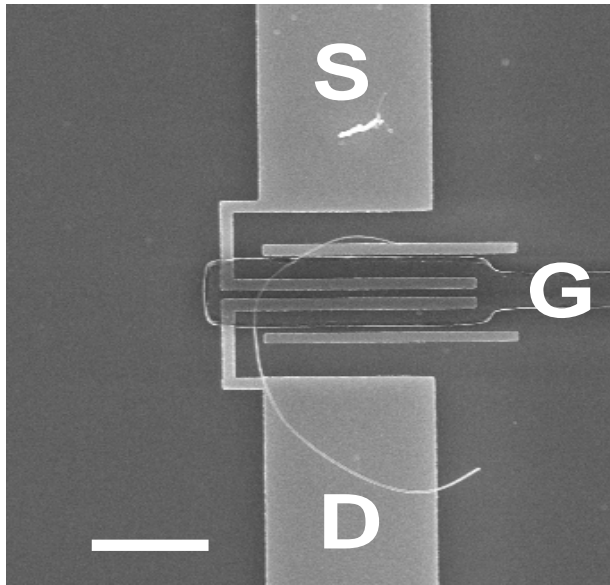
$$I_{ds} = \frac{\mu}{L_{eff}} \int_0^{V_{ds}} Q_{NW}(V_{gs}, V_{ds}) dV$$



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# Experimental Verification

Ge-Nanowire PFET, diameter=12nm,  
 $L_{eff} = 250\text{nm}$ ,  $T_{ox}=8\text{nm}(\text{HfO}_2)$



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